

09/08/2008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	: 10/623,866	Confirmation No.	: 6399
First Named Inventor	: Yoshihiro KATO		
Filed	: July 22, 2003		
TC/A.U.	: 1763		
Examiner	: J. Lund		
Docket No.	: 101246.52582US		
Customer No.	: 23911		
Title	: Plasma Process System and Plasma Process Method		

SUPPLEMENTAL AMENDMENT AND RESPONSE

Mail Stop AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to a telephone conversation with the Examiner and supplemental to the Amendment and Response under 37 C.F.R. §1.116 filed June 17, 2008, Applicant submits herewith the following Supplemental Amendment and Response.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this Response.

Remarks begin on page 7 of this Response.